



PATENT
Docket No. 606402017700

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In the application of:

Takashi NOMA *et al.*

Serial No.: 10/828,556

Filing Date: April 21, 2004

For: SEMICONDUCTOR DEVICE AND
MANUFACTURING METHOD
THEREOF

Examiner: Nitin Parekh

Group Art Unit: 2811

Conf. No.: 5433

PRELIMINARY AMENDMENT

MS RCE
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

Prior to the next examination of this application in consequence of the Request for Continued Examination filed concurrently herewith, please amend this application as follows:

The listing of the claims begins on page 2.

The remarks begin on page 5.